

PATENT ABSTRACTS OF JAPAN

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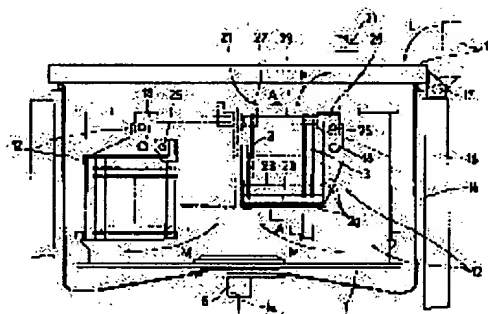
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(54) CENTRIFUGAL DRYER

(57)Abstract:

PURPOSE: To provide a centrifugal dryer which is downsized sufficiently even for a substrate having large diameter while shortening the drying time.

CONSTITUTION: A substrate holding means 12 for holding a cleaned substrate 3 directly is disposed rotatably on a turn table 1 while being set such that the main surface of the substrate 3 is normal to the center of rotation 1a of the turn table 1 at the time of centrifugal drying operation.



LEGAL STATUS

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